

Focusing Lens

It is challenging to simulate systems with optical lenses by the standard full vector wave analysis method because the number of mesh elements tends to be extremely large for the size of regular optical lenses. Since the standard frequency domain analysis solves for the electric field, the mesh needs to resolve the fast-oscillating field amplitude in order to get an accurate solution, that is, the maximum element size needs to be 1/5 of the wavelength or smaller. This standard method is suited for systems that are comparable to or up to ten times the wavelength. Compared to the standard method, the beam envelopes method is another type of full vector wave analysis that solves for the slowly varying envelope. With this method, the requirement for meshing is largely reduced depending on how slowly the envelope varies and therefore it is possible to solve systems with a large domain size. Lenses that are relatively smaller in size and are slow (focal length is not too small) may potentially be good candidates for the Electromagnetic Waves, Beam Envelopes interface in the Wave Optics Module, if the intensity computation is of interest.

In this model, a plano-convex focusing lens is analyzed by using the Electromagnetic Waves, Frequency Domain interface and the Electromagnetic Waves, Beam Envelopes interface. The computational results are compared. The Electromagnetic Waves, Frequency Domain interface analyzes only the lens domain and its vicinity. A boundary field at the exit plane of the lens is propagated to the focal plane by the Fresnel diffraction formula. The Electromagnetic Waves, Beam Envelopes interface analyzes the entire domain including the focal plane.

Model Definition

The plano-convex lens has a diameter of 0.2 mm, thickness of 15 µm, the radius of curvature of 0.5 mm, and the focal length of about 1 mm. The front surface of the lens is illuminated by a top-hat beam with a size of 0.1 mm, as depicted in Figure 1. This is a slow lens with a numerical aperture of about 0.05.

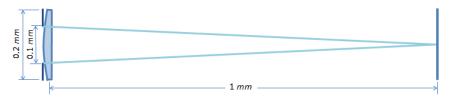


Figure 1: The optical layout.

The first study uses the Electromagnetic Waves, Frequency Domain interface to analyze the near field; that is, only the lens domain and its vicinity. After computing the near field, the electric field amplitude at the exit side of the lens is transformed to the focal plane by using the Fresnel diffraction formula (Ref. 1):

$$E(f, u) = \frac{1}{\sqrt{\lambda f}} \int_{-\infty}^{\infty} E(x_0, y) e^{-i\pi y^2/(\lambda f)} e^{i2\pi uy/(\lambda f)} dy$$

where λ is the wavelength; f is the focal length; and $u/(\lambda f)$ is called the spatial frequency; and $E(x_0, y)$ and E(f, u) are the electric field amplitudes at the exit plane $x = x_0$ and at the focal plane x = f, respectively.

To evaluate the integral above, an integration operator intop1 is defined on the boundary at the exit plane. The y coordinate in the focal plane, the coordinate u, is defined by a one-dimensional grid dataset. To make sure that u is evaluated on the grid dataset, and not on the exit plane boundary, the dest operator is applied to u. The dest operator forces the expression that it operates on to be evaluated on the destination points (the grid dataset points in this case) instead of the source points (the exit plane boundary). This means that the destination operator (dest) can be used to create convolution integrals and other integral transforms.

The second study uses the Electromagnetic Waves, Beam Envelopes interface to solve for the electric field norm in the entire domain, including the focal plane. In this simulation, it should be emphasized that the mesh element is as large as λ in the air domain, compared to the first study, in which the Electromagnetic Waves, Frequency Domain interface requires a mesh element of $\lambda/n/5$ everywhere in the near-field domain.

For both physics interfaces, a Transition boundary condition is used for approximating an anti-reflection (AR) coating applied to the lens surfaces. The Transition boundary condition has the advantage that the thin AR coating does not have to be represented, and thereby meshed, using a thin domain around the lens. Instead, the coating is approximated as a boundary condition.

For the Electromagnetic Waves, Frequency Domain interface, the Transition boundary condition is based on the assumption that the wave propagates in the normal direction to the boundaries within the thin AR coating layer. This is strictly not fulfilled in this model, but a good approximation as the waves propagate in directions quite close to the normal direction.

For the Electromagnetic Waves, Beam Envelopes interface, the Transition boundary condition is implemented either with the same assumption as described above or assuming that the waves propagate in the direction specified in the **Wave Vectors** section in the

settings for the physics interface. In this model, the latter option is chosen, assuming it is a slightly better approximation than the first option.

The refractive index for the AR coating,

$$n_{AR} = \sqrt{n_{\rm Lens}}$$
,

is specified in a material with a boundary selection. The thickness for the coating,

$$d_{\rm AR} = \frac{\lambda}{4n_{\rm AR}},$$

is specified in the Transition boundary condition nodes.

Results and Discussion

Figure 2 shows the result of the electric field amplitude in the computed near-field domain. The electric field amplitude at the exit plane (Figure 3) is transformed to the focal plane by using the Fresnel diffraction formula (Figure 4).

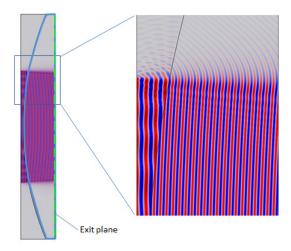


Figure 2: Electric field amplitude calculated in the near-field domain by using the Electromagnetic Waves, Frequency Domain interface. The aspect ratio is changed to 2:1.

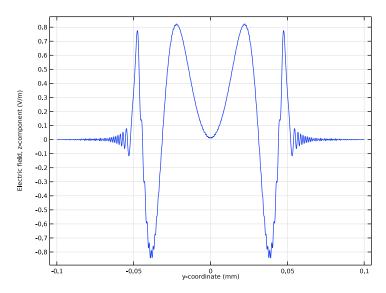


Figure 3: The electric field amplitude at the exit plane.

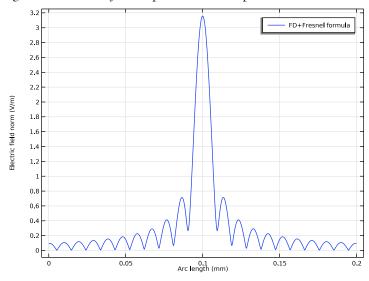


Figure 4: The norm of the transformed electric field at the focal plane.

Figure 5 is the electric field norm computed over the entire domain by using the Electromagnetic Waves, Beam Envelopes interface. Figure 6 compares the results of the

electric field norm at the focal plane between the Electromagnetic Waves, Frequency Domain interface and the Electromagnetic Waves, Beam Envelopes interface. The two methods agree very well.

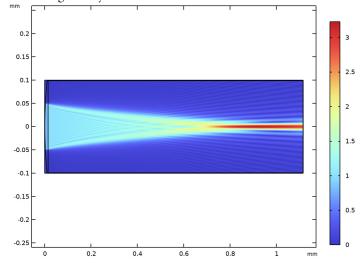


Figure 5: The electric field norm computed over the entire domain with the Electromagnetic Waves, Beam Envelopes interface.

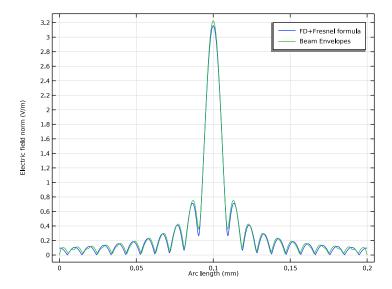


Figure 6: A comparison of the electric field norm at the focal plane between Electromagnetic Waves, Frequency Domain interface and Electromagnetic Waves, Beam Envelopes interface.

Reference

1. J.W. Goodman, Introduction to Fourier Optics, McGraw Hill.

Application Library path: Wave_Optics_Module/Verification_Examples/focusing_lens

Modeling Instructions

From the File menu, choose New.

NEW

In the New window, click Model Wizard.

MODEL WIZARD

I In the Model Wizard window, click **Q** 2D.

- 2 In the Select Physics tree, select Optics>Wave Optics>Electromagnetic Waves, Frequency Domain (ewfd).
- 3 Click Add.
- 4 Click Study.
- 5 In the Select Study tree, select Preset Studies for Selected Physics Interfaces> Wavelength Domain.
- 6 Click **Done**.

GLOBAL DEFINITIONS

To save time, the parameters can be loaded from a file.

Parameters 1

- I In the Model Builder window, under Global Definitions click Parameters I.
- 2 In the Settings window for Parameters, locate the Parameters section.
- 3 Click Load from File.
- 4 Browse to the model's Application Libraries folder and double-click the file focusing lens parameters.txt.

GEOMETRY I

- I In the Model Builder window, under Component I (compl) click Geometry I.
- 2 In the Settings window for Geometry, locate the Units section.
- 3 From the Length unit list, choose mm.

Rectangle I (rI)

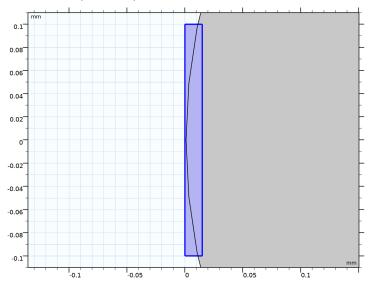
- I In the Geometry toolbar, click Rectangle.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- 3 In the Width text field, type W lens.
- 4 In the **Height** text field, type H.
- 5 Locate the **Position** section. In the y text field, type -H/2.

Circle I (c1)

- I In the Geometry toolbar, click Circle.
- 2 In the Settings window for Circle, locate the Size and Shape section.
- 3 In the Radius text field, type R.
- 4 Locate the **Position** section. In the **x** text field, type R+1[um].

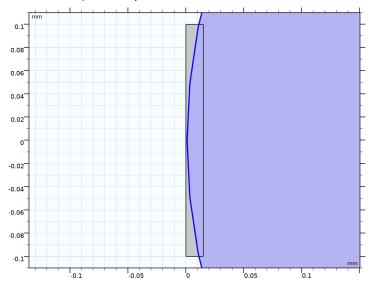
Partition Objects I (parI)

- I In the Geometry toolbar, click Booleans and Partitions and choose Partition Objects.
- 2 Select the object rI only.



- 3 In the Settings window for Partition Objects, locate the Partition Objects section.
- **4** Click to select the **Activate Selection** toggle button for **Tool objects**.

5 Select the object **c1** only.



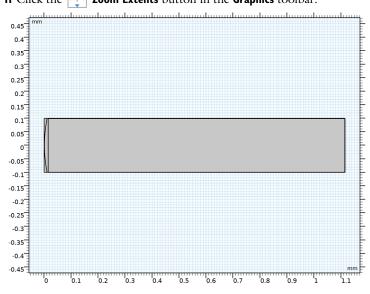
Rectangle 2 (r2)

- I In the Geometry toolbar, click Rectangle.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- 3 In the Width text field, type W_air.
- 4 In the Height text field, type H.
- **5** Locate the **Position** section. In the **x** text field, type W lens.
- 6 In the y text field, type -H/2.
- 7 Click to expand the Layers section. In the table, enter the following settings:

Layer name	Thickness (mm)
Layer 1	wl

- 8 Select the Layers to the right check box.
- **9** Select the **Layers on top** check box.
- 10 Click Build All Objects.

II Click the **Zoom Extents** button in the **Graphics** toolbar.



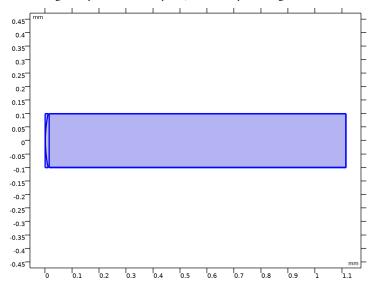
DEFINITIONS

Before continuing, add a few selections for use later on in the modeling process.

Air

- I In the **Definitions** toolbar, click **\(\bigcap_{\bigcap} \) Explicit**.
- 2 In the Settings window for Explicit, type Air in the Label text field.

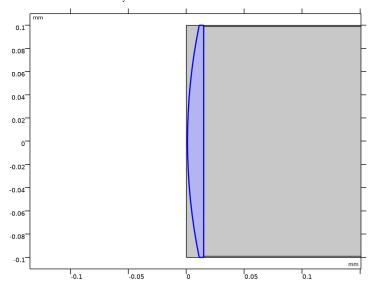
3 Select Domains 1 and 3-8 only, by first enabling the All domains check box, then selecting entity 2 in the entity list, and finally clicking the **Remove from Selection** button.



Lens

- I In the **Definitions** toolbar, click **\(\big|_{\text{a}} \) Explicit**.
- 2 In the Settings window for Explicit, type Lens in the Label text field.

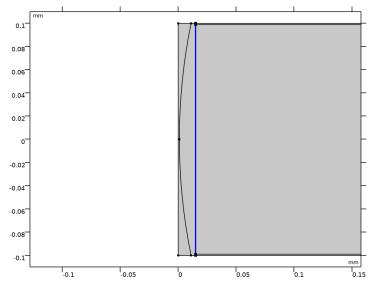
3 Select Domain 2 only.



Near Field

- I In the **Definitions** toolbar, click 🔓 **Explicit**.
- 2 In the Settings window for Explicit, type Near Field in the Label text field.
- 3 Locate the Input Entities section. From the Geometric entity level list, choose Boundary.

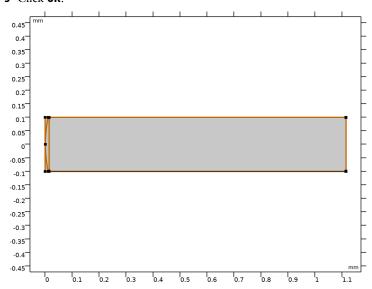
4 Select Boundaries 6, 8, and 10 only.



Boundaries Adjacent to Air

- I In the Definitions toolbar, click \P Adjacent.
- 2 In the Settings window for Adjacent, type Boundaries Adjacent to Air in the Label text field.
- 3 Locate the Input Entities section. Under Input selections, click + Add.
- 4 In the Add dialog box, select Air in the Input selections list.

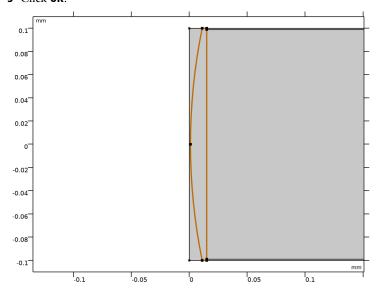
5 Click OK.



Boundaries Adjacent to the Lens

- I In the Definitions toolbar, click \P Adjacent.
- 2 In the Settings window for Adjacent, type Boundaries Adjacent to the Lens in the Label text field.
- 3 Locate the Input Entities section. Under Input selections, click + Add.
- 4 In the Add dialog box, select Lens in the Input selections list.

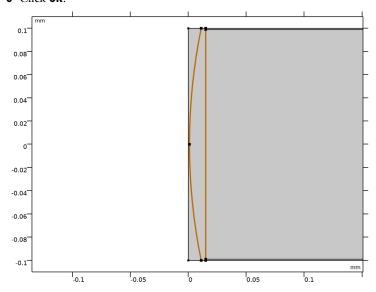
5 Click OK.



Boundaries Adjacent to Both Air and the Lens

- I In the **Definitions** toolbar, click **Intersection**.
- 2 In the Settings window for Intersection, type Boundaries Adjacent to Both Air and the Lens in the Label text field.
- 3 Locate the Geometric Entity Level section. From the Level list, choose Boundary.
- **4** Locate the **Input Entities** section. Under **Selections to intersect**, click + **Add**.
- 5 In the Add dialog box, in the Selections to intersect list, choose Boundaries Adjacent to Air and Boundaries Adjacent to the Lens.

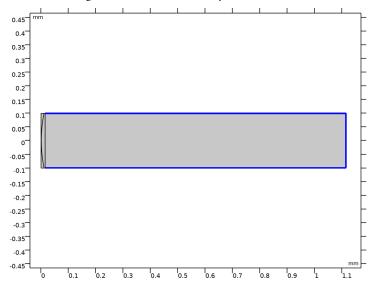
6 Click OK.



PMLs

- I In the Definitions toolbar, click 堶 Explicit.
- ${\bf 2} \;$ In the ${\bf Settings} \; {\bf window} \; {\bf for} \; {\bf Explicit}, \; {\bf type} \; {\bf PMLs} \; {\bf in} \; {\bf the} \; {\bf Label} \; {\bf text} \; {\bf field}.$

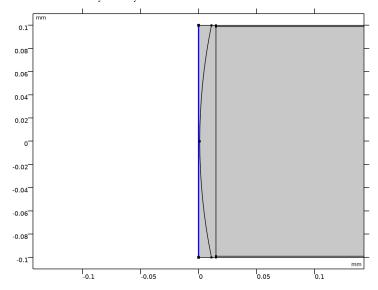
3 Select Domains 3 and 5–8 only, by first including domains 3-8 using the **Select Box** and then removing domain 4 from the entity list.



Input Boundary

- 2 In the Settings window for Explicit, type Input Boundary in the Label text field.
- 3 Locate the Input Entities section. From the Geometric entity level list, choose Boundary.

4 Select Boundary 1 only.



Now, add a variable representing the refractive index.

Variables 1

- I In the Model Builder window, right-click Definitions and choose Variables.
- 2 In the Settings window for Variables, locate the Variables section.
- **3** In the table, enter the following settings:

Name	Expression	Unit	Description
n	1		Air

- **4** Locate the **Geometric Entity Selection** section. From the **Geometric entity level** list, choose **Domain**.
- 5 From the Selection list, choose Air.

Variables 2

- I Right-click **Definitions** and choose **Variables**.
- 2 In the Settings window for Variables, locate the Variables section.
- **3** In the table, enter the following settings:

Name	Expression	Unit	Description
n	n_lens		Lens

- 4 Locate the Geometric Entity Selection section. From the Geometric entity level list, choose Domain.
- 5 From the Selection list, choose Lens.

To propagate the boundary field using the Fresnel diffraction formula in the first study, the integration operator is defined on the near-field boundary.

Integration I (intob I)

- I In the Definitions toolbar, click Nonlocal Couplings and choose Integration.
- 2 In the Settings window for Integration, locate the Source Selection section.
- 3 From the Geometric entity level list, choose Boundary.
- 4 From the Selection list, choose Near Field.

MATERIALS

Add materials for the lens and the surrounding air. The material for the AR coating will be added after the Transition boundary condition has been added to the physics.

Air

- I In the Model Builder window, under Component I (compl) right-click Materials and choose Blank Material.
- 2 In the Settings window for Material, type Air in the Label text field.
- 3 Locate the Geometric Entity Selection section. From the Selection list, choose Air.
- **4** Locate the **Material Contents** section. In the table, enter the following settings:

Property	Variable	Value	Unit	Property group
Refractive index, real part	n_iso ; nii = n_iso, nij = 0	1	I	Refractive index
Refractive index, imaginary part	ki_iso ; kiii = ki_iso, kiij = 0	0	I	Refractive index

Glass

- I Right-click Materials and choose Blank Material.
- 2 In the Settings window for Material, type Glass in the Label text field.
- 3 Locate the Geometric Entity Selection section. From the Selection list, choose Lens.

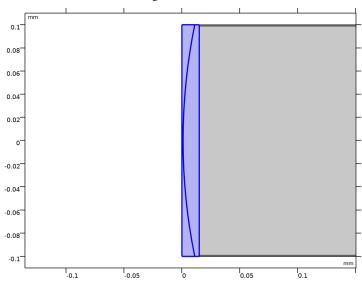
4 Locate the **Material Contents** section. In the table, enter the following settings:

Property	Variable	Value	Unit	Property group
Refractive index, real part	n_iso ; nii = n_iso, nij = 0	n_lens	I	Refractive index
Refractive index, imaginary part	ki_iso ; kiii = ki_iso, kiij = 0	0	I	Refractive index

ELECTROMAGNETIC WAVES, FREQUENCY DOMAIN (EWFD)

In the first study, the Electromagnetic Waves, Frequency Domain interface computes only the near-field.

- I In the Model Builder window, under Component I (compl) click Electromagnetic Waves, Frequency Domain (ewfd).
- **2** Select Domains 1 and 2 only, by selecting entities 3-8 in the entity list in the **Domain** Selection section and clicking the Remove from Selection button.



- 3 In the Settings window for Electromagnetic Waves, Frequency Domain, locate the **Components** section.
- 4 From the Electric field components solved for list, choose Out-of-plane vector.

Scattering Boundary Condition I

I In the Physics toolbar, click — Boundaries and choose Scattering Boundary Condition.

- 2 In the Settings window for Scattering Boundary Condition, locate the Boundary Selection section.
- 3 From the Selection list, choose Input Boundary.
- 4 Locate the Scattering Boundary Condition section. From the Incident field list, choose Wave given by E field.
- **5** Specify the \mathbf{E}_0 vector as

0	x
0	у
1[V/m]*(abs(y) <w)< td=""><td>z</td></w)<>	z

This defines an incident wave polarized in the z direction with a constant amplitude of, 1[V/m], inside the beamwidth 2*w.

Scattering Boundary Condition 2

- In the Physics toolbar, click Boundaries and choose Scattering Boundary Condition.
- 2 In the Settings window for Scattering Boundary Condition, locate the Boundary Selection section.
- 3 From the Selection list, choose Near Field.

Transition Boundary Condition I

Now, add a Transition boundary condition that represents the AR coating on the lens.

- In the Physics toolbar, click Boundaries and choose Transition Boundary Condition.
- 2 In the Settings window for Transition Boundary Condition, locate the Boundary Selection section.
- 3 From the Selection list, choose Boundaries Adjacent to the Lens.
- **4** Locate the **Transition Boundary Condition** section. In the d text field, type d_AR.

MATERIALS

Add the material for the AR coating.

AR Coating

- I In the Model Builder window, under Component I (compl) right-click Materials and choose Blank Material.
- 2 In the Settings window for Material, type AR Coating in the Label text field.
- 3 Locate the Geometric Entity Selection section. From the Geometric entity level list, choose Boundary.

- 4 From the Selection list, choose Boundaries Adjacent to the Lens.
- **5** Locate the **Material Contents** section. In the table, enter the following settings:

Property	Variable	Value	Unit	Property group
Refractive index, real part	n_iso ; nii = n_iso, nij = 0	n_AR	I	Refractive index
Refractive index, imaginary part	ki_iso ; kiii = ki_iso, kiij = 0	0	I	Refractive index

STUDY I

Step 1: Wavelength Domain

- I In the Model Builder window, under Study I click Step I: Wavelength Domain.
- 2 In the Settings window for Wavelength Domain, locate the Study Settings section.
- 3 In the Wavelengths text field, type w1.
- 4 In the Home toolbar, click **Compute**.

DEFINITIONS

To make a better plot, create a new view with a different aspect ratio.

View 2

In the Model Builder window, under Component I (compl) right-click Definitions and choose View.

Axis

- I In the Model Builder window, expand the View 2 node, then click Axis.
- 2 In the Settings window for Axis, locate the Axis section.
- 3 From the View scale list, choose Manual.
- 4 In the x scale text field, type 2.

RESULTS

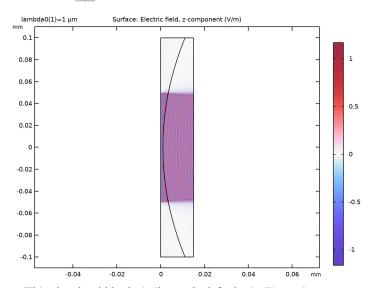
Electric Field (ewfd)

- I In the Model Builder window, under Results click Electric Field (ewfd).
- 2 In the Settings window for 2D Plot Group, locate the Plot Settings section.
- 3 From the View list, choose View 2.

Surface I

I In the Model Builder window, expand the Electric Field (ewfd) node, then click Surface I.

- 2 In the Settings window for Surface, locate the Expression section.
- 3 In the Expression text field, type ewfd.Ez.
- 4 Locate the Coloring and Style section. Click | Change Color Table.
- 5 In the Color Table dialog box, select Wave>WaveLight in the tree.
- 6 Click OK.
- 7 Click the **Zoom Extents** button in the **Graphics** toolbar.



This plot should look similar to the left plot in Figure 2.

Near Field

Now, create a plot of the near-field.

- I In the Home toolbar, click Add Plot Group and choose ID Plot Group.
- 2 In the Settings window for ID Plot Group, type Near Field in the Label text field.

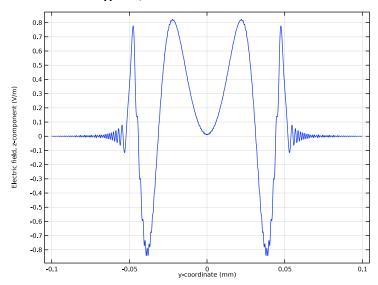
Line Graph 1

- I Right-click Near Field and choose Line Graph.
- 2 In the Settings window for Line Graph, locate the Selection section.
- 3 From the Selection list, choose Near Field.
- 4 Locate the y-Axis Data section. In the Expression text field, type ewfd. Ez.
- 5 Locate the x-Axis Data section. From the Parameter list, choose Expression.
- 6 In the Expression text field, type y.

7 In the Near Field toolbar, click Plot.

Near Field

- I In the Model Builder window, click Near Field.
- 2 In the Settings window for ID Plot Group, click to expand the Title section.
- 3 From the Title type list, choose None.



Grid ID I

To plot the transformed electric field at the focal plane, create a dataset for a new spatial variable u in the focal plane.

- I In the Results toolbar, click More Datasets and choose Grid>Grid ID.
- 2 In the Settings window for Grid ID, locate the Parameter Bounds section.
- 3 In the Name text field, type u.
- 4 In the Minimum text field, type -H/2.
- 5 In the Maximum text field, type H/2.

Focal Plane

- I In the Results toolbar, click \to ID Plot Group.
- 2 In the Settings window for ID Plot Group, type Focal Plane in the Label text field.
- 3 Locate the Title section. From the Title type list, choose None.
- 4 Locate the Plot Settings section.

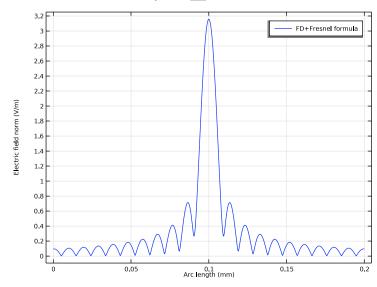
5 Select the y-axis label check box. In the associated text field, type Electric field norm (V/m).

Line Graph 1

- I Right-click Focal Plane and choose Line Graph.
- 2 In the Settings window for Line Graph, locate the Data section.
- 3 From the Dataset list, choose Grid ID 1. Type the expression for the Fresnel diffraction formula.
- 4 Locate the y-Axis Data section. In the Expression text field, type 3/2.5*sqrt(1/wl/f* intop1(ewfd.Ez*exp(-i*k*y^2/(2*f))*exp(i*2*pi*dest(u)*y/(wl*f)))* conj(intop1(ewfd.Ez*exp(-i*k*y 2 /(2*f))*exp(i*2*pi*dest(u)*y/(wl* f))))).
- 5 Click to expand the **Legends** section. Select the **Show legends** check box.
- 6 From the Legends list, choose Manual.
- 7 In the table, enter the following settings:

Legends	
FD+Fresnel	formula

8 In the Focal Plane toolbar, click Plot.



ADD PHYSICS

In the second part of this model, the Electromagnetic Waves, Beam Envelopes interface analyzes the entire domain.

- I In the Home toolbar, click and Physics to open the Add Physics window.
- 2 Go to the Add Physics window.
- 3 In the tree, select Optics>Wave Optics>Electromagnetic Waves, Beam Envelopes (ewbe).
- **4** Click **Add to Component I** in the window toolbar.
- 5 In the Home toolbar, click and Physics to close the Add Physics window.

DEFINITIONS

Perfectly Matched Layer I (pml1)

- I In the Definitions toolbar, click M. Perfectly Matched Layer.
- 2 In the Settings window for Perfectly Matched Layer, locate the Domain Selection section.
- 3 From the Selection list, choose PMLs.

ELECTROMAGNETIC WAVES, BEAM ENVELOPES (EWBE)

- I In the Model Builder window, under Component I (compl) click Electromagnetic Waves, Beam Envelopes (ewbe).
- 2 In the Settings window for Electromagnetic Waves, Beam Envelopes, locate the **Components** section.
- 3 From the Electric field components solved for list, choose Out-of-plane vector.
- 4 Locate the Wave Vectors section. From the Number of directions list, choose Unidirectional.
- **5** Specify the \mathbf{k}_1 vector as

k*n	x
0	у

Matched Boundary Condition I

- In the Physics toolbar, click Boundaries and choose Matched Boundary Condition.
- 2 In the Settings window for Matched Boundary Condition, locate the Boundary Selection section.
- 3 From the Selection list, choose Input Boundary.
- 4 Locate the Matched Boundary Condition section. From the Incident field list, choose Electric field.

5 Specify the \mathbf{E}_0 vector as

0	x
0	у
1[V/m]*(abs(y) <w)< td=""><td>z</td></w)<>	z

Transition Boundary Condition I

Also for this physics interface, add a Transition boundary condition to represent the AR coating on the lens surface.

- In the Physics toolbar, click Boundaries and choose Transition Boundary Condition.
- 2 In the Settings window for Transition Boundary Condition, locate the Boundary Selection section.
- 3 From the Selection list, choose Boundaries Adjacent to the Lens.
- 4 Locate the **Propagation Direction** section. From the list, choose **From wave vector**.

This setting assumes that the wave is incident on the Transition boundary condition boundaries with the wave vector as specified in the **Wave Vectors** section in the settings for the physics interface. This is a slightly better assumption than assuming that the wave propagates in the normal direction to the Transition boundary condition boundaries, which is what the other option represents.

5 Locate the **Transition Boundary Condition** section. In the d text field, type d AR.

ARTIFICIAL DOMAINS

Perfectly Matched Layer I (pml1)

- I In the Model Builder window, under Component I (compl)>Definitions>Artificial Domains click Perfectly Matched Layer I (pmII).
- 2 In the Settings window for Perfectly Matched Layer, locate the Scaling section.
- 3 From the Physics list, choose Electromagnetic Waves, Beam Envelopes (ewbe).

MESH I

- I In the Model Builder window, under Component I (compl) click Mesh I.
- 2 In the Settings window for Mesh, locate the Physics-Controlled Mesh section.
- 3 In the table, clear the Use check box for Electromagnetic Waves, Beam Envelopes (ewbe). This makes sure that the first mesh is controlled only by the Electromagnetic Waves, Frequency Domain interface.

COMPONENT I (COMPI)

Now, add a mesh used by the Electromagnetic Waves, Beam Envelopes interface.

MESH 2

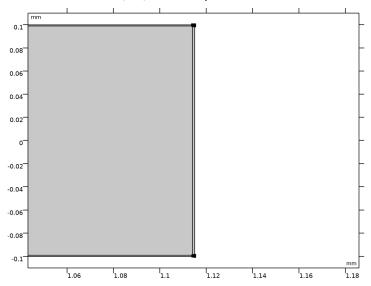
In the Mesh toolbar, click Add Mesh and choose Add Mesh.

Mapped I

- I In the Mesh toolbar, click Mapped.
- 2 In the Settings window for Mapped, locate the Domain Selection section.
- 3 From the Geometric entity level list, choose Domain.
- 4 From the Selection list, choose PMLs.

Distribution I

- I Right-click Mapped I and choose Distribution.
- **2** Select Boundaries 19, 20, and 22 only.



- 3 In the Settings window for Distribution, locate the Distribution section.
- 4 In the Number of elements text field, type 10.

Size

- I In the Model Builder window, under Component I (compl)>Meshes>Mesh 2 click Size.
- 2 In the Settings window for Size, locate the Element Size section.
- **3** Click the **Custom** button.

4 Locate the Element Size Parameters section. In the Maximum element size text field, type w1.

Free Triangular 1

In the Mesh toolbar, click Free Triangular.

ADD STUDY

- I In the Home toolbar, click Add Study to open the Add Study window.
- 2 Go to the Add Study window.
- 3 Find the Studies subsection. In the Select Study tree, select Preset Studies for Selected Physics Interfaces>Wavelength Domain.
- 4 Find the Physics interfaces in study subsection. In the table, clear the Solve check box for Electromagnetic Waves, Frequency Domain (ewfd).
- 5 Click Add Study in the window toolbar.
- 6 In the Home toolbar, click Add Study to close the Add Study window.

STUDY 2

Step 1: Wavelength Domain

- I In the Settings window for Wavelength Domain, locate the Study Settings section.
- 2 In the Wavelengths text field, type w1.
- 3 In the Home toolbar, click **Compute**.

DEFINITIONS

View 3

In the Model Builder window, under Component I (compl) right-click Definitions and choose View.

Axis

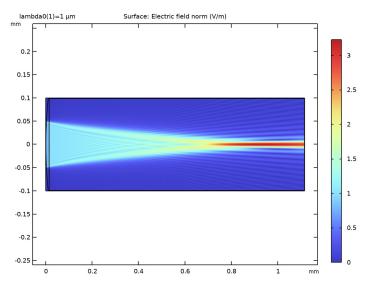
- I In the Model Builder window, expand the View 3 node, then click Axis.
- 2 In the Settings window for Axis, locate the Axis section.
- 3 From the View scale list, choose Manual.
- 4 In the y scale text field, type 2.

RESULTS

Electric Field (ewbe)

I In the Model Builder window, under Results click Electric Field (ewbe).

- 2 In the Settings window for 2D Plot Group, locate the Plot Settings section.
- 3 From the View list, choose View 3.
- 4 Click the **Zoom Extents** button in the **Graphics** toolbar.



Cut Line 2D I

Now create a plot comparing the results in the focal plane from the Fresnel diffraction formula of the near field from the Electromagnetic Waves, Frequency Domain solution and the Electromagnetic Waves, Beam Envelopes simulation for the whole domain.

- I In the Results toolbar, click Cut Line 2D.
- 2 In the Settings window for Cut Line 2D, locate the Data section.
- 3 From the Dataset list, choose Study 2/Solution 2 (sol2).
- 4 Locate the Line Data section. In row Point I, set X to f.
- 5 In row Point I, set Y to -H.
- 6 In row Point 2, set X to f.
- 7 In row Point 2, set Y to H.

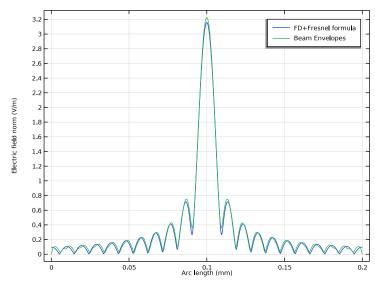
Line Graph 2

- I In the Model Builder window, right-click Focal Plane and choose Line Graph.
- 2 In the Settings window for Line Graph, locate the Data section.
- 3 From the Dataset list, choose Cut Line 2D 1.

- 4 Locate the y-Axis Data section. In the Expression text field, type ewbe.normE.
- **5** Locate the **Legends** section. Select the **Show legends** check box.
- 6 From the Legends list, choose Manual.
- 7 In the table, enter the following settings:

Legends Beam Envelopes

8 In the Focal Plane toolbar, click Plot.



Finally, create a plot of the field distribution along the optical axis.

Cut Line 2D 2

- I In the Results toolbar, click Cut Line 2D.
- 2 In the Settings window for Cut Line 2D, locate the Data section.
- 3 From the Dataset list, choose Study 2/Solution 2 (sol2).
- 4 Locate the Line Data section. In row Point 2, set X to W lens+W air-wl.

Propagation Direction

- I In the Results toolbar, click \sim ID Plot Group.
- 2 In the Settings window for ID Plot Group, type Propagation Direction in the Label text field.
- 3 Locate the Data section. From the Dataset list, choose Cut Line 2D 2.

- 4 Locate the Plot Settings section.
- **5** Select the **x-axis label** check box. In the associated text field, type Propagation length (mm).

Line Graph 1

- I Right-click Propagation Direction and choose Line Graph.
- 2 In the Settings window for Line Graph, locate the y-Axis Data section.
- **3** In the **Expression** text field, type ewbe.normE.
- 4 In the Propagation Direction toolbar, click Plot.

